

Attorney Docket No. 10112521

REPLY UNDER 37 CFR 1.116 –
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2823



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chich Shang CHANG et al

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Appl. No.: 10/628,893

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Art Unit: 2823

Title: METHOD FOR FORMING A SINGLE-CRYSTAL SILICON LAYER ON A
TRANSPARENT SUBSTRATE

Date: January 25, 2006

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE COVER SHEET

Sir:

Attached hereto please find a response to the Office Action mailed on October 31,
2005.

No fee is believed to be due in connection with the filing of this paper. If, however, the Commissioner considers that a fee is due in connection with the filing of this paper, authorization is made to charge any fee which may be required to Deposit Account No. 502447.

Nelson A. Quintero
Certificate of Mailing or Transmission

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(Name of Person Transmitting)

(Signature)

January 25, 2006

(Date)

Respectfully submitted,

Nelson A. Quintero
Nelson A. Quintero

Attorney for Applicant
Reg. No. 52,143
Customer No. 34,283

Telephone: (310) 401-6180

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